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September 25, 2002

FILE: 2000.076000

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BOX PATENT APPLICATION
Assistant Commissioner for Patents
Washington, DC 20231

RE: *U.S. Patent Application Serial No. 09/881,086*
Entitled: "USE OF A GETTERING AGENT IN A CHEMICAL MECHANICAL
POLISHING AND RINSING OPERATION AND APPARATUS
THEREFOR"
Inventor(s): Richard J. Markle
Client Reference: TT4638

Sir:

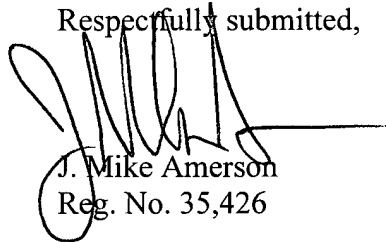
Enclosed for filing in the above-referenced patent application is a Supplemental Information Disclosure Statement, PTO-Form 1449 and references (B1-B8 and C1-C3).

No fees are believed to be due in connection with the filing of this Supplemental Information Disclosure Statement, however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be deemed necessary for any reason relating to the enclosed materials, the Assistant Commissioner is hereby authorized to deduct said fees from Advanced Micro Devices, Inc., Deposit Account No. 01-0365/TT4638.

WILLIAMS, MORGAN & AMERSON, P.C.
Assistant Commissioner for Patents
September 25, 2002
Page 2

Please date stamp and return the enclosed postcard evidencing receipt of these materials.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'J. Mike Amerson', with a horizontal line extending to the right.

J. Mike Amerson
Reg. No. 35,426

JMA/lb

Encl.

cc: Ms. Samantha Cardona (w/o encl.)



GP/1765
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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Richard J. Markle

Group Art Unit: 1765

Serial No.: 09/881,086

Examiner: Unknown

Filed: 06/13/2001

Atty. Dkt. No.: 2000.076000/TT4638

For: USE OF A GETTERING AGENT IN A
CHEMICAL MECHANICAL POLISHING
AND RINSING OPERATION AND
APPARATUS THEREFOR

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. §§ 1.97(g),(h), this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made, and is not to be

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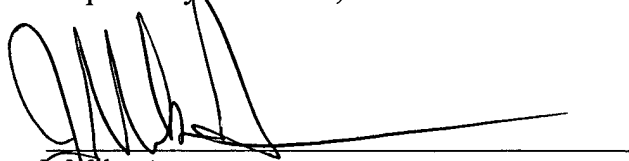
construed to be an admission that the information cited is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

The present Supplemental Information Disclosure Statement is being filed prior to the receipt of a first Official Action reflecting an examination on the merits, and hence is believed to be timely filed in accordance with 37 C.F.R. § 1.97(b). No fees are believed to be due in connection with the filing of this Supplemental Information Disclosure Statement, however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be deemed necessary for any reason relating to these materials, the Assistant Commissioner is hereby authorized to deduct said fees from Advanced Micro Devices, Inc., Deposit Account No. 01-0365/TT4638.

In accordance with 37 C.F.R. § 1.97(e)(1), Applicant hereby certifies that each item of information contained in this Supplemental Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the present statement, as evidenced by the date of the enclosed search report.

Applicant respectfully requests that the listed documents be made of record in the present case.

Respectfully submitted,

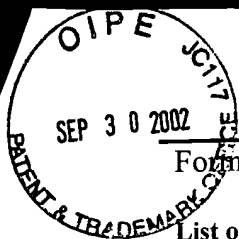


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Date: September 25, 2002



Form PTO-1449 (modified)

Atty. Docket No.
2000.076000Serial No.
09/881,086

List of Patents and Publications for Applicant's

Applicant
Richard J. Markle

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Filing Date:
June 13, 2001Group:
1765U.S. Patent Documents
See PageForeign Patent Documents
See Page 1Other Art
See Page 1

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
	A1						

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1	EP1096556A1	05/02/2001	EP			
	B2	EP0690483A2	01/03/1996	EP			
	B3	WO99/47618	09/23/1999	PCT			
	B4	WO98/26025	06/18/1998	PCT			
	B5	WO00/00567	01/06/2000	PCT			
	B6	WO00/34998	06/15/2000	PCT			
	B7	WO98/36045	08/20/1998	PCT			
	B8	WO97/03175	01/30/1997	PCT			

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Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C1	"Modification of the Preston Equation for the Chemical-Mechanical Polishing of Copper" Q. Luo, S. Ramarajan, S.V. Babu; <i>Thin Solid Films</i> 335 (1998) Pages 160-167.
	C2	"Initial Study on Copper CMP Slurry Chemistries" Ronald Carpio, Janos Farkas, Rahul Jairath; <i>Thin Solid Films</i> 266 (1995) pages 238-244.
	C3	International Search Report for PCT/US02/12829; mailed July 1, 2002.

EXAMINER:

DATE CONSIDERED:

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.